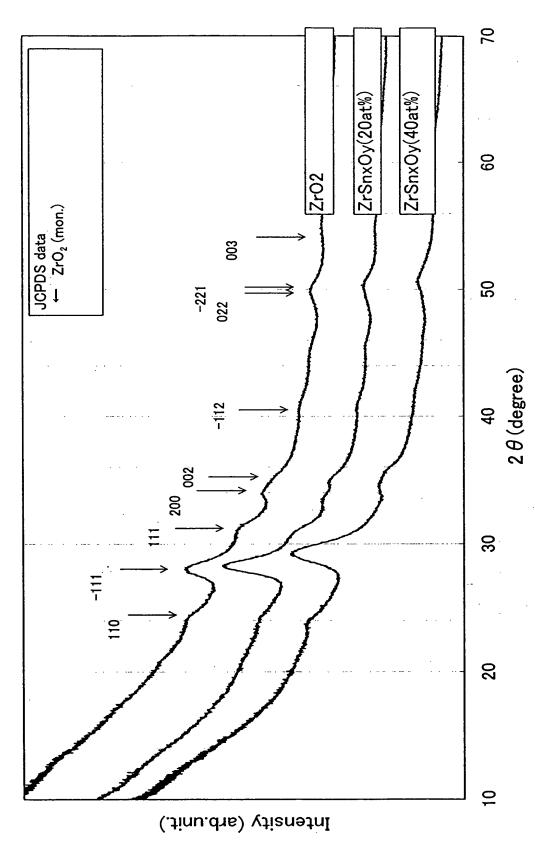
MAR 2 6 2004 W

XRD pattern of ZrO $_2$  and ZrSnxOy [Film composition SiO $_2$  (10nm) / ZrO $_2$  (150nm)]



XRD pattern of TiO<sub>2</sub> laminated on ZrO<sub>2</sub> and ZrSnxOy [Film composition SiO<sub>2</sub> (10nm) / ZrO<sub>2</sub> (25nm) / TiO<sub>2</sub> (150nm)]

